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: **1.** *Mattox, D.M.* Handbook of Physical Vapor Deposition (PVD) Processing// William Andrew Publishing/Noyes -1998. – P. 907. **2.** *Srolovitz D. J., Mazor A., Bukiet B. G.* Analytical and numerical modeling of columnar evolution in thin films //J. of Vac. Science & Technology.-1988.- Vol. A6.- P. 2371-2380. **3.** *Kohler U., Jensen C., Reshort K., et. al.* Homo- and heteroepitaxy of metal on metal growth// Structure dynamics in heterogeneous systems.-Singapore: World Scientific, 2001. – P. 140-147.